_ <del></del> _		Coonel Mont	DB	Time stamp
L Number	Hits 750	Search Text imag\$3 and semiconduct\$3 and pixel and	USPAT;	2003/04/28 06:11
-	750	electronic and silicon and (detector or	US-PGPUB	2003, 04, 20 00.11
		sensor) and read and layer and deposit\$3	00 10105	
	222004	(imag\$3 and semiconduct\$3 and pixel and	USPAT;	2003/04/23 09:54
-	333894	electronic and silicon and (detector or	US-PGPUB	2500,01,20 05.01
		sensor) and read and layer and deposit\$3)	22 20105	
		and matrix or array		
_	729	(imag\$3 and semiconduct\$3 and pixel and	USPAT;	2003/04/23 10:21
-	, 29	electronic and silicon and (detector or	US-PGPUB	
	İ	sensor) and read and layer and deposit\$3)		
		and (matrix or array)		
	7	((imag\$3 and semiconduct\$3 and pixel and	USPAT;	2003/04/23 10:22
	,	electronic and silicon and (detector or	US-PGPUB	
		sensor) and read and layer and deposit\$3)		
		and (matrix or array)) and vaporization		
_	308	((imag\$3 and semiconduct\$3 and pixel and	USPAT;	2003/04/23 10:22
	550	electronic and silicon and (detector or	US-PGPUB	
		sensor) and read and layer and deposit\$3)		
		and (matrix or array)) and vapor\$		
-	308	((imag\$3 and semiconduct\$3 and pixel and	USPAT;	2003/04/23 16:54
		electronic and silicon and (detector or	US-PGPUB	
		sensor) and read and layer and deposit\$3)		
		and (matrix or array)) and vapor\$7		
-	6	close adj space adj vapor adj transport	USPAT;	2003/04/23 17:37
			US-PGPUB	
-	0	(close adj space adj vapor adj transport)	USPAT;	2003/04/23 17:38
		and imag\$3	US-PGPUB	0000/04/00 05 05
-	77	250/370.12.ccls.	USPAT;	2003/04/23 17:39
			US-PGPUB	0000/04/00 17 50
-	378	250/338.4.ccls.	USPAT;	2003/04/23 17:39
			US-PGPUB	2002/04/02 17:40
-	1172	250/338.1.ccls.	USPAT;	2003/04/23 17:40
		050 (225 1)	US-PGPUB	2002/04/22 17:40
<b>–</b> ,	515	250/336.1.ccls.	USPAT;	2003/04/23 17:40
		050/270 011-	US-PGPUB	200 /04/23 17:41
-	483	250/370.01.ccls.	USPAT;	2000/04/23 17:41
		050/270 123-	US-PGPUB	2003/04/23 17:41
-	135	250/370.13.ccls.	USPAT; US-PGPUB	2003/04/23 17:41
	0.415	250/370.12.ccls. or 250/338.4.ccls. or	US-PGPUB USPAT;	2003/04/23 17:42
-	2415	250/3/0.12.ccls. or 250/338.4.ccls. or 250/338.1.ccls. or	US-PGPUB	2003/04/23 17:42
			US-FGFUB	
	042	250/370.01.ccls. or 250/370.13.ccls. (250/370.12.ccls. or 250/338.4.ccls. or	USPAT;	2003/04/23 17:42
-	842	250/338.1.ccls. or 250/336.1.ccls. or	US-PGPUB	2303,01,23 1,142
		250/338.1.ccls. of 250/330.1.ccls. of 250/370.13.ccls.) and	33 13105	
		imag\$3		
1_	337	((250/370.12.ccls. or 250/338.4.ccls. or	USPAT;	2003/04/23 17:44
	33/	250/338.1.ccls. or 250/336.1.ccls. or	US-PGPUB	
		250/370.01.ccls. or 250/370.13.ccls.) and		
		imag\$3) and pixel		
-	236	(((250/370.12.ccls. or 250/338.4.ccls. or	USPAT;	2003/04/24 11:42
		250/338.1.ccls. or 250/336.1.ccls. or	US-PGPUB	
		250/370.01.ccls. or 250/370.13.ccls.) and		
		imag\$3) and pixel) and semiconduct\$3		
-	1	(6548263.PN. and (((imag\$3 and	USPAT;	2003/04/23 17:45
		semiconduct\$3 and pixel and electronic and	US-PGPUB	
		silicon and (detector or sensor) and read		
		and layer and deposit\$3) and (matrix or		
	1	array)) and vapor\$7)) and (array or		
		matrix)		0000/01/01 == ::
<b>-</b>	. 0	(matrix or array) and semiconduct\$3 and	USPAT;	2003/04/24 11:44
		pixel and silicon and (reading adj panel)	US-PGPUB	
		and electronic and (vapor adj deposition)		2002/04/24 11:45
-	3029		USPAT;	2003/04/24 11:45
		pixel and (vapor adj deposition)	US-PGPUB	2003/04/24 11:45
-	0		USPAT;	2003/04/24 11:45
		pixel and (reading adj panel) and	US-PGPUB	
1	1	electronic and (vapor adj deposition)	l	

				T0002 (04 (04 11 - 45 )
_	0	(matrix or array) and semiconduct\$3 and	USPAT;	2003/04/24 11:45
		pixel and (reading adj panel) and (vapor	US-PGPUB	
		adj deposition)		, ,
-	2875	((matrix or array) and semiconduct\$3 and	USPAT;	2003/04/24 11:46
		pixel and (vapor adj deposition)) and	US-PGPUB	
		(silicon or SI)		
_ 1	2225	(((matrix or array) and semiconduct\$3 and	USPAT;	2003/04/24 11:46
		pixel and (vapor adj deposition)) and	US-PGPUB	
		(silicon or SI)) and imag\$3		
_	848	((((matrix or array) and semiconduct\$3 and	USPAT;	2003/04/24 11:47
		pixel and (vapor adj deposition)) and	US-PGPUB	
		(silicon or SI)) and imag\$3) and (detector		
		or sensor)		
_	575	(((((matrix or array) and semiconduct\$3	USPAT;	2003/04/24 11:54
		and pixel and (vapor adj deposition)) and	US-PGPUB	
		(silicon or SI)) and imag\$3) and (detector		
		or sensor)) and integrated		
<u>-</u>	81979	(vapor adj deposition)	USPAT;	2003/04/24 11:54
:			US-PGPUB	
_	9324	(vapor adj deposition) with semiconductor	USPAT;	2003/04/24 11:55
			US-PGPUB	
-	187	(vapor adj deposition) near semiconductor	USPAT;	2003/04/24 11:55
			US-PGPUB	_
_	10	((vapor adj deposition) near	USPAT;	2003/04/24 12:01
		semiconductor) and imag\$3	US-PGPUB	
_	1400		USPAT;	2003/04/24 12:03
		semiconductor) and imag\$3	US-PGPUB	
_	335		USPAT;	2003/04/24 12:03
		semiconductor) and imaging	US-PGPUB	
_	9825	, , , , , , , , , , , , , , , , , , , ,	USPAT;	2003/04/28 06:12
		, ,	US-PGPUB	
l <u>-</u>	476	((vapor adj deposition) with semiconduct\$3	USPAT;	2003/04/28 06:12
İ		) and pixel	US-PGPUB	
_	4	1 · · · · · · · · · · · · · · · · · · ·	USPAT;	2003/04/28 06:12
		semiconduct\$3 ) and pixel) and	US-PGPUB	
		scintillat\$3		
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